

Image



520.39440X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): S. UTO, et al  
Serial No.: 09/764,457  
Filed: January 19, 2001  
For: ULTRAVIOLET LASER-GENERATING DEVICE AND DEFECT  
INSPECTION APPARATUS AND METHOD THEREFOR  
Group: 2881  
Examiner: P. Johnston

**STATEMENT OF SUBSTANCE OF INTERVIEW**


Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 20, 2004

Sir:

Applicants note that an Interview Summary accompanied the Notice of Allowance and confirm that the undersigned attorney conducted a telephone interview with the Examiner, Phillip Johnston, on January 15, 2004, during which time amendments to the claims as effected by the Examiner's Amendment accompanying the Notice of Allowance and Interview Summary, were discussed and authorized in order to place the application in condition for allowance. Thus, applicants confirm the substance of the interview as provided by the Interview Summary and although applicants consider the submission of this paper to be unnecessary, to avoid any question concerning the requirements for applicant to file a statement of the substance of the interview, this statement is submitted.

Respectfully submitted,

  
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Melvin Kraus  
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